

B. Amendment to the Claims

The following is a complete listing of the claims, and replaces all earlier versions and listings.

1. (Original) A method of manufacturing an electronic device, comprising the steps of:
 - (i) providing a substrate on which a pair of electrodes is arranged; and
 - (ii) arranging a carbon nanotube to electrically connect the electrodes.
2. (Original) A method of manufacturing an electronic device, comprising the steps of:
 - (i) providing a substrate on which a pair of electrodes is arranged; and
 - (ii) forming a carbon nanotube electrically connecting the electrodes.
3. (Original) The method according to claim 1 or 2, wherein said step (ii) comprises forming the carbon nanotube by a CVD method.
4. (Original) The method according to claim 3, further comprising a step of providing a catalyst on one of the electrodes.
5. (Original) The method according to claim 3, further comprising a step of providing a catalytic particle on one of the electrodes.

6. (Currently Amended) The method according to claim 4, wherein the catalyst ~~comprises~~ is selected from the group consisting of iron, cobalt ~~[[or]]~~ and nickel.

7. (Currently Amended) The method according to claim 5, wherein the catalytic particle ~~comprises~~ is selected from the group consisting of iron, cobalt ~~[[or]]~~ and nickel.

8. (Original) The method according to claim 5, wherein a diameter of the catalytic particle is not more than 5×10^{-8} m.

9. (Original) The method according to claim 5, wherein a diameter of the catalytic particle is not less than 1×10^{-9} m.